

Application No. 10/823,887

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No10/823,887
Filing Date.....April 13, 2004
Inventorship Brian A. Vaartstra
AssigneeMicron Technology, Inc.
Group Art Unit.....1722
Examiner.....R. Kunemund
Attorney's Docket NoMI22-2489
Title: Aluminum-Containing Material and Atomic Layer Deposition Methods

RESPONSE TO AUGUST 9, 2005 OFFICE ACTION

To: Mail Stop Amendments
Commissioner for Patents and Trademarks
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Alexandria, VA 22313-1450

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AMENDMENTS

No amendments.